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Reactive Removal of BiF Ground State

Prepared by

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The reactivity of the ground state of bismuth monofluoride, $BiF(XO^+)$, has been investigated with a number of fluorine atom donors at several different temperatures. The measurements have been accomplished both by means of a time resolved, photolytically initiated experiment and on steady-state densities in a flow tube reactor. Both methods provide consistent results. The rate coefficients obtained span a range of over 3 orders of magnitude: F₂ is found to be fairly efficient (2.0 x 10⁻¹¹ cm³/molecule-sec) while the series of nitrogen fluorides NF₂, NF₃, N₂F₄ is quite inert (6.2, 5.0, 7.8 x 10⁻¹⁵ cm³/molecule-sec, respectively). We observe BiF(XO⁺) formation with a rate coefficient of 8.1 x 10⁻¹² cm³/molecule-sec from NF₂ + Bi following the photolysis of Bi(CH₃)₃ at 193 nm. We are also able to estimate a formation constant for Bi + F₂ of about 1 x 10⁻⁹ , cm³/molecule-sec. The stability of Bi(CH₃)₃ with NF₂ is discussed.

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PREFACE

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I. INTRODUCTION

This laboratory's acquaintance with the bismuth monofluoride molecule began with the observation of its blue $AO^+ \rightarrow XO^+$ emission system during the course of flow tube studies.¹ The object of that research² was to scale the density of excited bismuth atoms based on resonant energy transfer from NF(a¹ Δ):

$$NF(a^{1}\Delta) + Bi({}^{4}S_{3/2}) \rightarrow NF(X^{3}\Sigma^{-}) + Bi({}^{2}D_{3/2}).$$
 (1)

Instead of achieving the anticipated increase in $Bi(^2D)$ as NF(a) densities were raised, the experiment resulted in the generation of significant amounts of electronically excited $BiF(AO^+)$. Its visible band system,³ 1.4 µsec radiative lifetime,⁴ and the apparent efficiency of its production are attributes which combine to make the AO⁺ state of BiF attractive as an acceptor of electronic energy from NF(a). This process is a complex combination of energy pooling and reactive transfer which has yet to be satisfactorily elucidated. Nevertheless, the NF/BiF system is one of a small number of visible wavelength chemical laser systems currently receiving serious consideration.

There remains a considerable list of kinetic issues to be resolved. As the lower laser level of the potential lasing transition, the fate of the BiF(XO⁺) is of particular concern. Evidence suggests that BiF is repetitively pumped, resulting in several $A \rightarrow X$ photons for every Bi atom in the system. Current models of the reaction mechanism involve either the reduction of BiF(XO⁺) to reform the parent Bi atom or a sequential, two-step energy transfer from NF(a).¹ The principal oxidation states of bismuth are +3 and +5; both BiF₃ and BiF₅ are stable materials. Any process that leads to the further oxidation of BiF will remove it from the repetitive pump/lase cycle and thereby lower the overall mass efficiency of the device. We report here a study of the reactive removal of the ground state of BiF with F₂ and a series of nitrogen fluorides; NF₂, NF₃, and N₂F₄.

II. EXPERIMENTAL

Two separate sets of apparatus were required to perform the BiF ground-state kinetics experiments. Steady-state measurements were made with a fixed observation point flow tube using a Broida oven⁵ to generate a continuous flow of BiF(XO⁺). Because of the difficulty of accurately characterizing the various flow parameters (e.g., centerline flow velocity, see section III), these measurements were made on a relative basis. In order to obtain absolute rate coefficients, a parallel set of photolytically initiated, time-resolved experiments were conducted in a separate photolysis cell on slowly flowing, pre-mixed samples. Both experimental approaches rely on cw laser-induced fluorescence on the BiF AO^+-XO^+ transition to monitor BiF(XO⁺) population. Schematic representations of both setups are shown in Figure 1.

The Broida oven/flow tube is a modification of the apparatus which we have previously employed in kinetics studies of $BiF(AO^+)$.^{4,6} It is constructed of 4 in. nominal diameter sections of stainless steel and is operated as a flow tube in a vertical orientation. The cell is defined by two regions, the oven section and the observation region, separated by a stainless steel bulkhead. The oven consists of an alumina crucible suspended in a resistively heated tungsten basket. The crucible is filled with Bi metal. It is heated to a temperature of about 850 K, as measured by a thermocouple in contact with the outer surface of the crucible. A flow of Ar is introduced over the surface of the metal, and a stream of entrained Bi vapor is swept out of the oven section through a funnel-shaped, cylindrical stainless steel stack, 0.95 cm in diameter, which projects through the bulkhead. A dilute flow of F₂ (10% in He) is injected into the stack and reacts to form BiF. The crucible, tungsten filament, and gas injectors are all enclosed within an alumina housing. The stack terminates about 5 cm above the floor of the observation region as defined by the bulkhead. A quartz ring injector introduces reactant/diluent mixtures into the observation region. A quartz cylinder, 8.5 cm i.d., wrapped with nichrome wire, serves as a temperaturecontrolled inner wall. At the observation point, 12 cm above the end of the stack, the quartz wall is drilled through (1 cm diameter) to permit the passage of the probe laser beam. A larger port (2.5 cm diameter) is located at right angles to these holes for viewing the laser-induced fluorescence (LIF). The laser light enters and exits the cell through baffled arms equipped with Brewster-angle Suprasil windows. The LIF is collected via f/1 optics and observed through a 1.0 nm (FWHM) interference filter centered at 470.1 nm near the A-X (1,4) bandhead by a photomultiplier tube (PMT) (EMI 6256). Photon counting (Stanford Research Systems, SR400) is employed, a technique which provides a dynamic range of more than five decades. Background chemiluminescence and scattered laser light determine the sensitivity of the measurement. In all cases, this noise level is below 10³ counts/sec, whereas our steady-state LIF signal levels are taken in the range of 5 $x 10^5 - 2 \times 10^4$ counts/sec, affording the measurement excellent signal/noise ratios. The 6.5 I cell is evacuated by a 500 l/min pump. Flow rates are determined with mass flowmeters (Tylan) which were calibrated in situ. Total flow rates are on the order of 750 cm³ atm/ min.



(a) Photolysis cell.



(b) Broida oven/flow tube showing detail of oven.



Pressure in the observation region of the flow tube is measured with a capacitance manometer with 10 m torr resolution (MKS Baratron). The temperature at the observation point of the flow is determined with a thermocouple located directly above the axis of the probe laser.

The photolysis cell has been described in detail previously.⁷ Briefly, it consists of a 4.6 cm i.d. stainless steel tube 25 cm in length equipped with three orthogonal observation ports. The inner surface of the cell is Teflon coated to alleviate the effects of any wall-mediated processes. Windows on the photolysis axis are mounted on the end of 15 cm extensions to reduce scattered laser light at the observation region of the cell. The cell is wrapped with heating tape and insulated to allow operating temperatures of up to 200°C. As with the flow tube apparatus, calibrated mass flowmeters are used to measure flow rates, and cell pressure is determined with a capacitance manometer. Experiments are conducted on slowly flowing (< 0.25 l-atm/min) premixed samples. In the case of the fluorine bearing reagents, mixing into the main flow is accomplished in a 0.5 in. diameter section of tubing immediately before the gas flow enters the main body of the cell. This point is of consequence to the issue of the stability of the reagents in a premixed situation. Where N_2F_4 is used, it is first flowed through a quartz bulb maintained at 190°C to assure its virtually complete pyrolysis to NF₂^{8,9} Ground-state densities of BiF are generated via the reaction of Bi atoms with either NF_2 or F_2 . The Bi atoms are prepared by the ArF laser (Lambda Physik EMG 101) photolysis of trimethylbismuth, Bi(CH₃)₃, at 193 nm. Neither of the fluorine bearing reagents demonstrates an appreciable absorption at this wavelength. In order to minimize side reactions between reagents and photolysis products (chiefly CH₃) fragments), the ArF laser fluence was attenuated by means of a stack of uncoated quartz flats to the lowest energy consistent with good signal-to-noise levels (3-4 mJ). BiF A-X LIF is observed through a 1.0 nm (FWHM) interference filter centered at 459.4 nm (corresponding to the A-X (1,3) bandhead) by a PMT identical to the one used on the flow tube experiments. A 25 MHz transient digitizer (LeCroy 2264) takes the time resolved data which is averaged and stored on a lab computer (DEC LSI 11/23 +).

In both experiments, the BiF ground state is monitored via LIF resulting from pumping of v'' = 0 using a cw ring dye laser (Coherent 699-21) with a bandwidth of about 500 kHz and single frequency powers of 150-250 mW. The pumped transition is P(24) of the A-X (1.0) band at 430.186 nm (vacuum). A wavemeter (Burleigh WA-20) is used to coarsely tune the wavelength of the laser. Fine tuning is accomplished by maximizing the BiF LIF intensity under initial experimental conditions with no reactant present. The laser frequency is actively locked to a cavity mode to ensure that there is no shift in wavelength during the experiment.

The following reagents were used without further purification: Ar (Matheson, 99.999%), F_2 (Spectra Gases, 1% in Ar and 10% in He). SF₆ (Alphgaz, 99.99%), N₂F₄ (Hercules, 10% and 60% in Ar), NF₃ (Matheson, 99.9%), and Bi(CH₃)₃ (ICN Pharmaceuticals, 0.1% in Ar).

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III. RESULTS AND DISCUSSION

The rationale for following two experimental approaches in the course of this work derives from the nature of the species of interest, $BiF(XO^+)$, and the methodology of generating it in experimentally useful quantities. Bismuth fluoride has been observed following the photolysis of mixtures of NF₂ and Bi(CH₃)₃ at both 248 and 193 nm. However, production of a ground-state population of BiF in this manner presents some undesirable complications, not the least of which are the uncharacterized reactions of reagents and photolysis fragments (e.g., NF₂ + CH₃). As an alternative, we have used a Broida-type evaporative metal oven and subsequent oxidation to generate a continuous flow of BiF.

The use of a Broida oven entails its own complications. The primary difficulty is encountered in achieving a well characterized flow at the observation point. In order to put an amount of Bi vapor into the flow which will lead to a useful dynamic range over which to make the measurement, it is necessary to flow the Ar carrier gas at a rate that accounts for over 35% of the entire gas flow. The design of the oven is such that the BiF/Ar flow is introduced into the mixing and observation region of the apparatus through a 1 cm diameter orifice. As a result, the plug flow velocity of the entrained BiF at its point of entry into the observation region is about 30 times that calculated for the total flow in the 8 cm diameter observation region. This leads to an initially steep radial concentration gradient for BiF outside of the region defined by the central oven-flow. Further, the transport velocity¹⁰

$$v(r) = 2v_{pf}(1 - r^2/R^2),$$
(2)

where v_{pf} is the plug flow velocity, R is the tube radius, and r is the distance along the radius, is expected to be greater at the centerline than the $2v_{pf}$ suggested by the total flow rate and observation region diameter. It is chiefly because of the difficulty of accurately characterizing the transport velocity that we have chosen to perform relative measurements, comparing two different reactants for a given set of flow conditions. This approach removes much of the systematic uncertainty inherent in the experiment. We then turn to a time-resolved, photolytically initiated experiment to make an absolute determination of the rate coefficient for BiF + F₂, which serves as the standard reaction to which our relative rate coefficients may be compared.

A. FLOW TUBE KINETIC MEASUREMENTS

OLDIn order to obtain relative rates of reaction using the flow tube apparatus, the following technique is employed. A set of conditions (total flow rate, pressure, and temperature) is established which is maintained throughout the course of the experimental run. We then record BiF LIF intensity for a number of partial pressures of a particular reactant, varying the reactant/buffer gas ratio while maintaining a constant total flow rate. The result is a set of data which varies exponentially with reactant density as is expected for pseudo first-order decay;

$$[BiF] = [BiF]_{o}exp(-k_x[X]t)$$
(3)

where k_x is the rate coefficient for the process of BiF + X. Two assumptions are implicit in our use of LIF as a monitor of ground-state BiF population. First, because the laser accesses a single rovibrational level of the ground state, we assume that the sample is in thermal equilibrium. The transit time to the observation point (about 16 msec), and total pressure at which the experiment is conducted (2.3 torr), ensures that the sample is vibrationally and rotationally relaxed. The second assumption is that the LIF signal intensity is proportional to the BiF ground-state population and is not affected by BiF A state kinetics. The influence of excited state kinetics is reduced due to the relatively rapid BiF(A)radiative decay. For example, an F_2 + BiF(A) removal rate constant 3 orders of magnitude larger than that for BiF(X) would only cause a 50% reduction in BiF(A) population during its 1.4 μ sec radiation lifetime⁴ for our runs having the highest F₂ densities. In the case of NF₂, the BiF A state removal rate coefficient would have to be over 4 orders of magnitude greater than BiF(X) removal for the same effect. Results from the timeresolved experiments, in which the decay of the A + X LIF intensity is strictly proportional to [BiF(X)], are in good agreement with the flow tube study, providing further evidence that excited state kinetics do not influence the flow tube measurements.

Figure 2 displays plots of BiF(XO⁺) removal by F_2 and NF₃ at 21°C, F_2 and N₂F₄ at 36°C, and F_2 and NF_2 at 200°C, and their least squares exponential fits. The fits to the data provide coefficients (in units of cm³/molecule) which represent the product k_x where t is the transport time of the BiF from its point of injection into the mixing region of the reactor to the observation point and is taken to be constant for a given set of conditions. It will be noted that the F_2 data extrapolates to a significantly larger intercept than does its partner in each of the three data sets. The reactants employed in these experiments are capable of both the initial oxidation of Bi atoms to form BiF and further reaction to remove it. Because the experiment is constrained to a single fixed observation point and reaction distance, it is not possible to uniquely resolve formation and removal processes. Care is taken that the F_2 injected into the entrained Bi stream in the oven section to form BiF is present in sufficient excess so that no unreacted Bi remains. The F₂ data suggest that some further BiF formation does take place at low reactant densities. In the regime in which the data is taken, however, the decay of the signal is single exponential with reactant density. We take this as indicative that the process we are following is completely dominated by the removal of BiF, with no contribution due to its formation. The agreement of these results with the photolytic experiments bears this assumption out.

The experimental sets are always performed as pairs, with one reaction treated as the standard against which the others are compared. We have chosen the rate of

$$BiF + F_2 \rightarrow BiF_2 + F \tag{4}$$

as the standard rate for these measurements. Table 1 summarizes the results of the flow tube determinations for NF₂, N_2F_4 , and NF₃, as well as the absolute rate coefficients obtained from our time-resolved measurements. Error limits quoted are the rms errors



(c) Data for NF_2 and F_2 at 200 °C

Figure 2. BiF A-X Laser-Induced Fluorescence Intensity Plotted as a Function of Reactant Density. F_2 density is represented by circles and reactant density by triangles. Solid lines are least squares single exponential fits to the data.

X	Method	Temperature (K)	k _x /k _{F2}	$k_x(cm^3/molecule-sec)$
F ₂	Time Resolved	298		2.1 (0.2) x 10- ¹¹
F ₂	Time Resolved	463		2.0 (0.2) x 10- ¹¹
NF ₂	Flow Tube	473	3.08×10^{-4}	6.2 (2.2) × 10- ¹⁵
NF ₂	Time Resolved	471		3.9 (1.0) x 10- ¹⁵
NF ₃	Flow Tube	294	2.51×10^{-4}	$5.0(1.4) \times 10^{-15}$
N ₂ F ₄	Flow Tube	309	3.91 × 10 ⁻⁴	7.8 (1.6) x 10^{-15}
BiF Formation				
$Bi + NF_2$	Time Resolved	468		8.1 (1.9) x 10 ⁻¹²
$Bi + F_2$	Time Resolved	298		~1 x 10 ⁻⁹

 Table 1. Results of BiF + X

based on 2σ from the nonlinear least squares fits to the data. The flow tube experiments provide us with relative rate coefficients, k_x/k_{F_2} . We require an absolute value for k_{F_2} .

Performing our kinetic measurements in a relative fashion presents a number of advantages. Because we duplicate flow tube conditions for each of the reactants for a given experimental run, we obtain relative rate coefficients which are independent of the uncertainties associated with the flow dynamics. The principal deviation from this assumption arises from the difference in the diffusivities of the various reactants, in so far as mixing of the reactants into the BiF flow is incomplete. Given the distance from the reactant injector to the observation point (15 cm) and reactor pressure (2.3 Torr), this effect is negligible. Reactant concentrations are varied such that the same range of steady-state intensities is observed in each case. As a result, any contribution from axial diffusion to the overall transport velocity will be the same for each set of measurements.

Analysis of the removal of BiF by N_2F_4 at 3^{\prime} \subset requires that the equilibrium concentration of NF₂ be accounted for. At this temperature, NF₂ is present at levels of 10 to 50% that of N_2F_4 depending on the overall partial pressure of two species.^{8,9} The observed rate of removal of BiF is simply the sum of the products of the reactant densities and their associated rate coefficients.

$$R_{obs} = (k_{N_2F_4} [N_2F_4] + k_{NF_2}[NF_2])$$
⁽⁵⁾

The BiF density at the observation point is

$$[BiF] = [BiF]_0 \exp\left[-(k_{N_2F_4}[N_2F_4] + k_{NF_2}[NF_2])t\right]$$
(6)

To extract the ratio $k_{N_2F_4}/k_{F_2}$ from the flow tube intensity data, each experimental point is scaled according to the previously obtained rate coefficient for NF₂ at 200°C, the partial

pressure of NF₂ for that measurement, and the transport time, t. The transport time is calculated on the basis of comparison of the corresponding F₂ data with the results of our time resolved measurements. No correction is made for any temperature dependence of the NF₂ rate coefficient. The rate coefficients for the monomer and dimer are similar enough that, when no correction is made for the partial pressure of NF₂, a coefficient of 8.9×10^{-15} is obtained, well within the error of the value we quote for $k_{N_{2}F_{4}}$.

A summary of bond dissociation energies derived from available thermochemical data for bismuth and nitrogen fluorides is presented in Table 2. Although the BiF-F and BiF₂-F bond energies for BiF₂ and BiF₃ are not known, the average bond energy of BiF₃ is 91.1 kcal/mol.¹¹ Estimates of the bond strength of BiF(XO⁺), based on spectroscopic evidence, range from 74 kcal/mol^{3,12} to 115 kcal/mol on the basis of a LeRoy-Bernstein longrange analysis of the BiF(XO⁺) state in recent work by Ross, et al.¹³ The N-F bond energy increases with decreasing degree of fluorination ranging from 59.3 kcal/mol for NF₂-F to 71.7 kcal/mol for NF(X). Also included in the table are the NF(a) and NF(b) dissociation energies, calculated using NF spectroscopic data.^{15,16} Assuming a release of 90 kcal/ mol for the formation of the second BiF-F bond, the fluorination of BiF(XO⁺) by NF₂ and F₂ will be exothermic by 23 kcal/mol and 53 kcal/mol, respectively.

SPECIES	Dissociati		
	(cm ⁻¹)	kcal/mole	Reference
F ²	12920(50)	36.93(0.10)	14
NF(b) ^(a)	25100(2800)	71.5(7.9)	16
NF(a) ^(a)	32600(2800)	93.2(7.9)	15
NF(X)	25000(2800)	71.7(7.9)	14
NF-F	23500(2800)	67.2(7.9)	14
NF ₂ -F	20700(700)	59.3(1.9)	14
BiF	25800	74	3,12
BiF ^(b)	31900(590)	91.1(1.7)	11
BiF	40000	115	13

Table 2. Bismuth and Nitrogen Fluoride Bond Dissociation Energies

^(a)Calculated using the NF(X) bond energy and spectroscopic data, where the dissociated atoms are assumed to be $N(^{2}D)$ and $F(^{2}P)$.

(b)Average bond strength from the enthalpy of atomization.

The rate coefficients which we report for the different nitrogen fluorides are statistically the same. Essentially the same processes of bond formation and cleavage are being undergone in each instance with the same thermochemistry dominating the reaction. From the point of view of a simple Arrhenius interpretation, there is apparently not a strong temperature dependence for the reaction. However, the estimated error in the rate coefficients we report is sufficiently large to disguise an activation barrier of up to about 1 kcal/ mol. Zero or negative temperature dependencies are often attributed to the formation of bound intermediates¹⁷ where the observed rate reflects the equilibria of the transition complex with both the starting material and the products. Alternatively, steric differences among the various reactants may serve to counter the effect of temperature on the rates which we observe. An explicit investigation of the rate of the reaction as a function of temperature is necessary before any conclusions may be drawn concerning the microscopic detail of the process. The use of NF₃ as the test case would provide a system that is stable over a wide range of temperatures with the salient features of NF₂/N₂F₄, in particular the 60–70 kcal/mol N-F bond and the lone pair of electrons on the central N atom.

B. PHOTO-INITIATED KINETICS

Once the relative rates of reaction have been established, an absolute rate coefficient must be determined for our baseline reaction, $BiF + F_2$. To this end we have performed a time-resolved experiment based on ArF laser photolysis of $Bi(CH_3)_3$ at 193 nm and the subsequent formation and removal of BiF by F_2 . Measurements were performed at 20 and 190°C. As a check of our flow tube results, we have measured \Rightarrow rate of removal of BiF with NF₂ at 190°C. We have also determined the rate of formation of BiF from Bi + NF₂. We conclude with some observations on stability of these reagents with regard to one another in so far as it affects the ability to premix these compounds.

In order to minimize the effect of undesired side reactions on our measurement, both the ArF photolysis laser flux and the initial $Bi(CH_3)_3$ density were held to relatively low values (3 mJ and 2-3 x 10¹² molecules/cm³, respectively). Experimental conditions were chosen where $[F_2] > 10[Bi(CH_3)_3]$ so that loss of F_2 due to the generation of BiF and any side reactions would be insignificant. Our method is simple. Fluorine reacts rapidly with the Bi atoms generated by the 193-nm photolysis of $Bi(CH_3)_3$ to form BiF. On the timescale of the subsequent decay of the BiF LIF signal, the resultant time-resolved traces are well represented by a single exponential decay. Figure 3 provides an example of the signal and its nonlinear least squares fit. Fits of this data provide rates of removal which are in turn plotted against the F_2 density at which the data were taken, as in Figure 4. The slope of the linear least squares fit to the rate vs density data yields the rate coefficient for the process. Care was taken to ensure that the rates we measure are a function only of F_2 density and do not include contributions from relaxation of a nascent product distribution or unwanted side reactions. SF_6 is employed as a constituent of the buffer gas mixture to promote the rapid vibrational relaxation of the reaction products. Previous work⁷ has shown SF_6 to be an efficient vibrational quencher of BiF(A). Variations in the partial pressure of SF₆ have no effect on the measured rate of decay of the LIF signal. Similarly, the observed rates are invariant to excursions in Bi(CH₃)₃ density. The cluster of eight points in Fig. 4 confirms that the decay rates are dependent only on F₂. The rate coefficient determined for BiF + F₂, 2.0×10^{-11} cm³/molecule-sec, forms the basis for the analysis of the flow tube measurements. The rate coefficient determined for BiF + F_2 , 2.0 x 10⁻¹¹ cm^3 /molecule-sec, forms the basis for the analysis of the flow tube measurements.



Figure 3. Time-resolved BiF A-X Laser-Induced Fluorescence from the 193 nm Photolysis of a Mixture of F_2 (1.37 x 10¹⁴ molecules/cm³), Ar (1.87 x 10¹⁷ atoms/ cm³), SF₆ (7.55 x 10¹⁶ molecules/cm³), and Bi(CH₃)₃ (7.76 x 10¹² molecules/ cm³) at 25°C. The solid line is a least squares single exponential fit to the data.



Figure. 4. Plot of BiF A-X Laser-Induced Fluorescence Decay Rates from the 193 nm Photolysis of $F_2/Ar/SF_6/Bi(CH_3)_3$ Mixtures at 25°C. The solid line is a linear fit to the data and has a slope of $2.1 \pm 0.3 \times 10^{-11}$ cm³/molecule-sec. The cluster of data points near $[F_2] = 1.5 \times 10^{14}$, which is the result of variations in the partial pressures of SF₆ and Bi(CH₃)₃, demonstrates that the rate is solely a function of F₂ density.

Similar experiments were performed with NF₂ as the oxidant. The use of low photolysis energy and small Bi(CH₃)₃ concentrations was especially necessary in these instances. Where higher fluences and Bi(CH₃)₃ densities were employed, the resulting LIF signals could only be fit to double exponential decays. We take this as indicative of reaction of NF₂ with photolysis fragments. Figure 5 displays a decay rate vs density plot for NF₂. The rate coefficient which we obtain for BiF + NF₂ from our time resolved measurements, 3.9×10^{-15} cm³/molecule-sec, compares reasonably well with the results of the flow tube work. The two values are within about 40% of one another and agree within their limits of error. We prefer the later value despite its somewhat larger error bars. Although photolytically initiated experiments are necessary to analyze the results, the Broida oven/ flow tube measurements are performed on a system which is largely free of complications arising from the presence of uncharacterized side reactions.

It was observed that the risetime of the BiF LIF signal from $Bi + NF_2$ was resolvable within our experimental bandwidth. A plot of the rate of formation of BiF vs NF₂ density is also shown in Figure 5. The rate coefficient for the formation of $BiF(XO^+)$ from Bi + NF_2 is also reported in Table I. The BiF risetime from Bi + F_2 was too rapid to be resolved at high F_2 densities, and at low F_2 densities the signal-to-noise ratio suffered due to the reaction of F_2 with Bi(CH₃)₃. Although we were not able to achieve satisfactory results, attempts to determine the BiF formation rate indicate that the reaction is extremely fast, on the order of 1×10^{-9} cm³/molecule-sec. It must be noted that there is a wide disposition in the energy levels of Bi atoms produced by the 193-nm photolysis of $Bi(CH_3)_3$ ⁷ In particular, the upper lying spin-orbit states of the 6p³ ground-state configuration are optically metastable and may be expected to participate in the reaction to form BiF. Therefore, the measurement is made over an ensemble of energy states of the the Bi atom. The value of 8.1 x 10^{-12} cm³/molecule-sec is within reasonable agreement with unpublished results from our laboratory of the rate coefficient for the removal of $Bi(^{2}D_{3/2})$ by NF₂ of $\leq 1.2(0.3) \times 10^{-11}$. Whereas the latter value is specific with regard to the collision partners, the formation constant must be viewed as a weighted average over the various states of Bi present; primarily the ⁴S_{3/2} ground state and the first excited ²D_{3/2} spinorbit state. As such, the agreement between the two measurements is rather good and, unless the Bi(${}^{4}S_{3/2}$) and Bi(${}^{2}D_{3/2}$) rate constants are similar, these results suggest that the $Bi(^{2}D_{3/2})$ state dominates either the reaction or the photolytic population distribution at early times.

The formation of BiF in the photolytic experiments is complex. A significant amount of energy is present in the form of electronic excitation of the Bi atoms. The term energy of $Bi(^{2}D_{3/2})$ if 11419 cm⁻¹ (32.6 kcal/mol).¹⁹ In addition, the products possess a number of low-lying electronic states. Assuming a bond energy of 90 kcal/mol for BiF, the NF₂ + Bi($^{2}D_{3/2}$) reaction can liberate as much as 55 kcal/mol, and 23 kcal/mol is available from the NF₂ + Bi($^{4}S_{3/2}$) reaction.^{16,17,20} Thus, a large number of exothermic channels are possible.



(a) BiF A-X LIF Decay Rate vs NF₂ Density. Solid line is a linear fit to the data with a slope of $3.9 \pm 0.5 \times 10^{-15}$ cm³/molecule-sec.



fit to the data with a slope of $9.0 \pm 1.0 \times 10^{-12} \text{ cm}^3/\text{molecule-sec.}$

Figure 5. Plots of BiF A-X Laser-Induced Fluorescence Decay and Rise Rates from ArF Laser Initiation of NF₂/Ar/SF₆/Bi(CH₃)₃ Mixtures at 198°C.

$$Bi(^{4}S_{3/2} + NF_{2} \rightarrow BiF(X0+) + NF(^{3}\Sigma^{-}) \quad \Delta H = -22.8 \text{ kcal/mol}$$
(7a)

$$BiF(X1) + NF(X^{3}\Sigma^{-}) \quad \Delta H = -2.0 \text{ kcal/mol}$$
(7b)

$$Bi(^{2}D_{3/2}) + NF_{2} \rightarrow BiF(XO^{+}) + NF(X^{3}\Sigma^{-}) \Delta H = -55.4 \text{ kcal/mol}$$
(7c)

$$BiF(X1) + NF(X^{3}\Sigma^{-}) \quad \Delta H = -34.6 \text{ kcal/mol}$$
(7d)

$$BiF(a2) + NF(X^{3}\Sigma^{-}) \quad \Delta H = -13.7 \text{ kcal/mol}$$
(7e)

$$BiF(XO^+) + NF(a^{1}\Delta) \Delta H = -22.7 \text{ kcal/mol}$$
(7f)

$$BiF(X1^+) + NF(b^1\Delta) \quad \Delta H = -1.9 \text{ kcal/mol}$$
(7g)

$$BiF(XO^{+}) + NF(b^{1}\Delta) \Delta H = -1.4 \text{ kcal/mol}$$
(7h)

The formation of charge-transfer complex intermediates has been suggested in the reaction of alkali metal atoms with halogen molecules.¹⁸ In a somewhat different context, a simplified long range attractive potential model has been applied to the formation of Bi(${}^{2}D_{3/2}$) from Bi + NF($a^{1}\Delta$) (Reaction 1).¹⁹ The model proposes a curve crossing from the covalent M + X₂ surface to the charge-transfer complex potential surface for M⁺ + X₂⁻. The crossing occurs at a separation R_{0} determined by the potential energy of the neutral collision pair, given at large R by

$$U(R_0) = IP(M) - EA(X_2)$$
(8)

where IP(M) is the ionization potential of the metal atom and $EA(X_2)$ is the electron affinity of the halogen. The potential of the ion pair may be approximated by coulombic and charge-induced dipole terms:

$$U(R) = -e^{2}/R - e^{2}(\alpha^{+} + \alpha^{-})/2R^{4}$$
(9)

where e is the unit of elementary charge and α^+ and α^- are the polarizabilities of the ion pair. For the present case of Bi + F₂, we take IP(Bi ⁴S, ²D) = 7.28, 5.86 eV.²⁰ and EA(F₂) = 3.08 eV.²¹ The polarizability of Bi⁺ is estimated using Slater's rules.²² α^+ = 2.96 x 10⁻²³ cm³. We take the polarizability of F₂⁻, to be somewhat greater than that of O₂, α^- = 2.4 x 10⁻²⁴ cm.^{3,22} Equating the two potentials yields reactive cross sections of 64 and 113 Å for Bi(⁴S) and Bi(²D) + F₂, respectively.² The cross sections in turn correspond to rate coefficients of 3.5 and 6.3 x 10⁻¹⁰ cm³/molecule-sec. Considering the conceptual simplicity of the model, agreement with the experiment is quite good. The results also lend some credence to our earlier supposition that Bi(²D_{3/2}) is the major reactive species in the photolytically initiated environment.

Bell and Husain²³ have measured the removal of Bi(⁴S) with Br₂. The rate constant they report, 5.3×10^{-13} cm³/molecule-sec, suggests that a different mechanism is operative.

The primary differences of that system in comparison to the present case are to be found in the electron affinity of $Br_2 (2.5 \text{ eV})^{21}$ and the restriction of the measurement to groundstate Bi. Both these considerations have the effect of lowering the long range covalent potential by about 2 eV relative to $Bi(^{2}D) + F_{2}$. This results in the prediction of an equipotential separation of somewhat less than 4 Å, which is well within the covalent hard-sphere collision diameter for Bi + Br_{2} .^{22,24} Thus, for a crossing to occur, it would necessarily have to take place on a repulsive slope of the potential surface of the reaction.

Trainor²⁵ has measured the rate of reaction of $Bi(^2D) + O_2$ over a range of temperatures. His reported rate coefficients (0.37 – 1.2 x 10^{-12} cm³/molecule-sec, T = 300 – 450 K) suggest that the reaction proceeds under the influence of the thermodynamic barrier rather than by means of a long range attractive potential. The electron affinity of O_2 , 0.44 eV,²⁶ is less than half that of the Bi atom (0.946 eV).²⁷ There is no propensity for an electron jump to take place.

During the course of the experiments described here, it was noticed that the initial BiF LIF intensities declined with increasing NF₂. We investigated this effect by simultaneously interrupting the reagent flows and sealing the flow cell. We monitored Bi(CH₃)₃ in absorption using the output of a deuterium lamp restricted by an interference filter at 206 nm and detected with a monochromator and PMT. At 211°C, with no NF₂ present, the Bi(CH₃)₃ displayed a characteristic lifetime in the photolysis cell of almost 200 sec before presumably being decomposed on the walls. This characteristic time increased by nearly a factor of 10 at 20°C, although the effect is complicated somewhat by fairly rapid (0.02 sec⁻¹) initial decay which we take to be adsorption on the cell walls. However, the addition of NF₂ at elevated temperature removes Bi(CH₃)₃ with a rate constant of 2 x 10⁻¹⁸ cm³/molecule-sec. Figure 6 displays our measured disappearance rates as a function of NF₂ density at 205°C. This process is of no consequence to the present study, but must be considered in such instances where Bi atom densities must be scaled via the UV photolysis of Bi(CH₃)₃.

The slow pace at which the N-F bond is converted to Bi-F in the removal of BiF is of positive import for the NF(a)-driven BiF chemical laser system. The pumping of $BiF(AO^+)$ by NF(a) is thought to proceed via an intermediate BiF electronic state in a two-step mechanism,

$$BiF(X) + NF(a) \rightarrow BiF^{*} + NF(X)$$
(10)

followed by

$$BiF^{\bullet} + NF(a) \rightarrow BiF(A) + NF(a).$$
(11)



Figure 6. Plot of Bi(CH₃)₃ Single Exponential Removal Rates by its Reaction with NF₂ at 205°C. Solid line has a slope of $2.4 \pm 1.5 \times 10^{-18} \text{ cm}^3/\text{molecule-sec}$.

Rate constants for each step are estimated to be of the order of 10^{-10} to 10^{-11} cm³/molecule-sec,^{28,29} several orders of magnitude larger than the NF₂ + BiF(X) rate coefficient reported here. Thus removal of BiF(X) due to reaction with NF₂ will not compete effectively with NF(a) pumping in such systems where [NF(a)] >> [NF₂]. While F₂ has proven to remove BiF efficiently, it does not exist in substantial density in the laser medium.

VI. CONCLUSION

We have measured the rate of removal of BiF in its ground electronic state with a series of fluorine atom donors. The kinetics were determined using both flow tube and time-resolved techniques. Both methods yield consistent results. While F_2 is found to be relatively fast, the series of nitrogen fluorides, NF₂, NF₃, and N₂F₄, are all quite inefficient.

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